



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant: KITAOKA et al. Examiner: Unknown
Serial No.: 10/757,864 Group Art Unit: Unknown
Filed: January 15, 2004 Docket: 10873.1391US01
Title: METHOD OF MANUFACTURING GROUP III NITRIDE SUBSTRATE AND SEMICONDUCTOR DEVICE

CERTIFICATE UNDER 37 CFR 1.8:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, with sufficient postage, in an envelope addressed to: , Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on March 17, 2004.

By: *[Signature]*
Name: Jennifer Holden

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450



Sir:

We are transmitting herewith the attached:

- ☒ Transmittal Sheet in duplicate containing Certificate of Mailing
- ☒ Certified copy of a Japanese application, Serial No. 2003-011570, filed January 20, 2003, the right of priority of which is claimed under 35 U.S.C. 119
- ☒ Signed Combined Declaration and Power of Attorney
- ☒ Communication regarding Missing Parts
- ☒ Information Disclosure Statement, Form 1449, 2 References
- ☒ Check in the amount of \$130 for Declaration Surcharge
- ☒ Return postcard

Please consider this a PETITION FOR EXTENSION OF TIME for a sufficient number of months to enter these papers or any future reply, if appropriate. Please charge any additional fees or credit overpayment to Deposit Account No. 13-2725. A duplicate of this sheet is enclosed.

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DPM/jh